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Section 8

19035/37209  
**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s):	)	
	)	
YASUHIRO KOI, ZUMI, ET AL.	)	Title: ION PLATING DEVICE AND
	)	ION PLATING METHOD
Serial No: 09/812,668	)	
	)	
Filed: March 20, 2001	)	

**TRANSMITTAL OF EXECUTED DECLARATION**

**Commissioner for Patents  
Washington, D.C. 20231**

**Attention: BOX MISSING PART**

Sir:

Submitted herewith is an executed Declaration for filing in the above-identified application. We have not received a Notice to File Missing Parts for this application.

**CERTIFICATE OF MAILING (37 CFR 1.8)**

I hereby certify that this paper and the documents referred to as enclosed therewith are being deposited with the United States Postal Service as first class mail, postage prepaid, on May 4, 2001 in an envelope addressed to Commissioner for Patents, Washington, D.C. 20231.

05/14/2001 KZEMDIE 00000031 09812668

01 FC:105

130.00 DP

*Nate Scarpelli*  
Nate F. Scarpelli

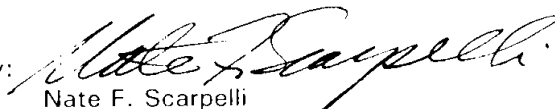
Also enclosed is our check in the amount of \$130.00 in payment of the fee.

The Commissioner is hereby authorized to charge any deficiency in the amount enclosed or any additional fees which may be required under 37 CFR 1.16 or 1.17 to Deposit Account No. 13-2855. A copy of this request is enclosed.

Please refund any overpayment to Marshall, O'Toole, Gerstein, Murray & Borun at the address below.

Respectfully submitted,

MARSHALL, O'TOOLE, GERSTEIN,  
MURRAY & BORUN  
6300 Sears Tower  
233 South Wacker Drive  
Chicago, Illinois 60606-6402  
(312) 474-6300

By:   
Nate F. Scarpelli  
Reg. No: 22,320

May 4, 2001